

10/583103

10/583103 16 JUN 2005

Docket No.: 12810-00278-US1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Lars Wittenbecher et al.

Application No.: National Phase of PCT/EP04/014275

Confirmation No.: N/A

Filed: Concurrently Herewith

Art Unit: N/A

For: COPPER(I) FORMATE COMPLEXES

Examiner: Not Yet Assigned

**INFORMATION DISCLOSURE STATEMENT (IDS)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement accompanies the new patent application submitted herewith.

Applicant has not submitted copies of each cited U.S. patent and U.S. patent application as required by 37 CFR 1.98(a)(2)(i), amended October 2004, as the U.S. Patent and Trademark Office has waived this requirement for all U.S. patent applications. Applicant submits herewith copies of foreign and non-patents in accordance with 37 CFR 1.98(a)(2).

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information

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as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 03-2775, under Order No. 12810-00278-US1.

Dated: June 16, 2006

Respectfully submitted,

By  52834

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Substitute for form 1449A/B/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>			<b>Complete if Known</b>		
			Application Number	Not Yet Assigned <b>10/583103</b>	
			Filing Date	Concurrently Herewith	
			First Named Inventor	Lars Wittenbecher	
			Art Unit	N/A	
			Examiner Name	Not Yet Assigned	
Sheet	1	of	2	Attorney Docket Number	12810-00278-US1

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
	AA*	US-5,141,602	08-25-1992	Chen et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
	BA	CN-12 40 689		01-12-2000	Univ Chinese Sci & Tech	
	BB	JP-06/184 749		07-05-1994	Dowa Mining Co Ltd	
	BC	WO-01/13426		02-22-2001	Steag RTP Systems Inc.	
	BD	DE-41 38 722		05-27-1993		
	BE	EP-0 976 847		02-02-2000	MicroCoating Technologies Inc	
	BF	DE-39 22 233		01-17-1991		
	BG	WO-01/94291		12-13-2001	Chi, Yun	
	BH	DE-103 25 243		12-23-2004	BASF AG	
	BI	EP-1 077 084		02-21-2001	Mitsubishi Gas Chemical Co Inc	
	BJ	EP-0 368 231		05-16-1990	Mitsubishi Gas Chemical Co Inc	
	BK	JP-11/193 461		07-21-1999	Arisawa MFG Co Ltd	
	BL	WO-036 053895		07-03-2003	EI Du Pont De Nemours and Co	

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NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
	CA	T.T. Kotas et al., The Chemistry of Metal CVD, 1994, p. 239-302		
	CB	D.K. Sohn et al., Ahn in Electrochem. Soc. 144 (1977), 3592-3596		
	CC	F.A. Cotton et al., Inorg. Chem. 39 (2000), 6072-6079		
	CD	E. Iljina et al., Mater. Sci. Eng. B18 (1993) 234-236		
	CE	S.A. Krupoder et al., J. Fluorine Chem. 73 (1995) 13-15		
	CF	M.E. Gross, J. Electrochem. Soc. 138 (8) (1991) 2422-2426		
	CG	K. Kohler et al., Organometallics 22 (2003) 4426-4432		
	CH	J.K. Kim et al., J. Korean Phys. Soc. 35 (5) (1999) 426-430		
	CI	M.J. Mouche et al., Adv. Sci. Technol. (Adv. Inorg. Films and Coatings) 5 (1995) 231-238		
	CJ	M.J. Mouche et al., Thin Solid Films 262 (1995) 1-6		
	CK	R. Padiyath et al., Metallized Plastics 2 (1991) 113-120		
	CL	R. Padiyath et al., J. Appl. Phys. 73(5) (193) 2326-2332		

Examiner Signature	Date Considered
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PTO/SB/08a/b (07-05)

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Sheet	2	of	2	Attorney Docket Number	12810-00278-US1

	CM	J.K. Kim et al., January 1999, SPIE Conf. on Laser Applications in Microelectronic and Optoelectronic Manufacturing IV, San Jose, CA, USA (Proceedings SPIE-Int. Soc. Opt. Eng. 3618 (1999) 378-385	
	CN	Keller et al., Natura 162 (1948) 580-582	
	CO	D.A. Edwards, J. Chem. Soc. Dalton Trans. 1973, 2463-2468	
	CP	B. Begiun et al., J. Organomet. Chem. 208 (1981) C18-C20	
	CQ	N. Marisch et al., J. Organomet. Chem. 239 (1982) 429-437	
	CR	C. Bianchini et al., J. Organomet. Chem. 248 (1983) C13-C16	
	CS	G. Doyle et al., Organometallics 1 (1982) 1613-1618	
	CT	J. Chem. Soc., Trans., vol. 5, 2000, 753-761, XP008053157	
	CU	J. Inorg. Nucl. Chem., vol. 33, 1971, 1017-1024, XP 002347077	
	CV	Inorg. Chem., vol. 24, n. 6, 1985, 924-931, XP002347078	

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